

FIG. 2

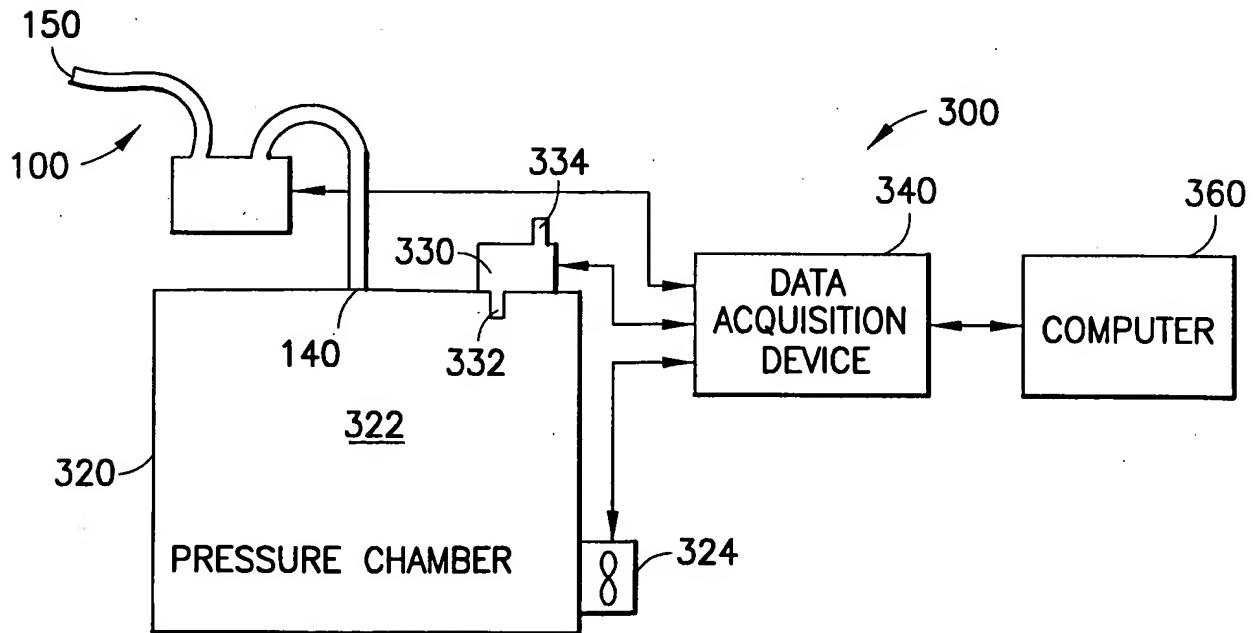


FIG. 3



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For: MICROFLOW BASED  
DIFFERENTIAL PRESSURE SENSOR  
Appln. No.: 10/021,860  
Filing Date: December 13, 2001  
Atty. Docket: 364106/0286  
Sheet No. 3 of 3

FORMAL DRAWINGS

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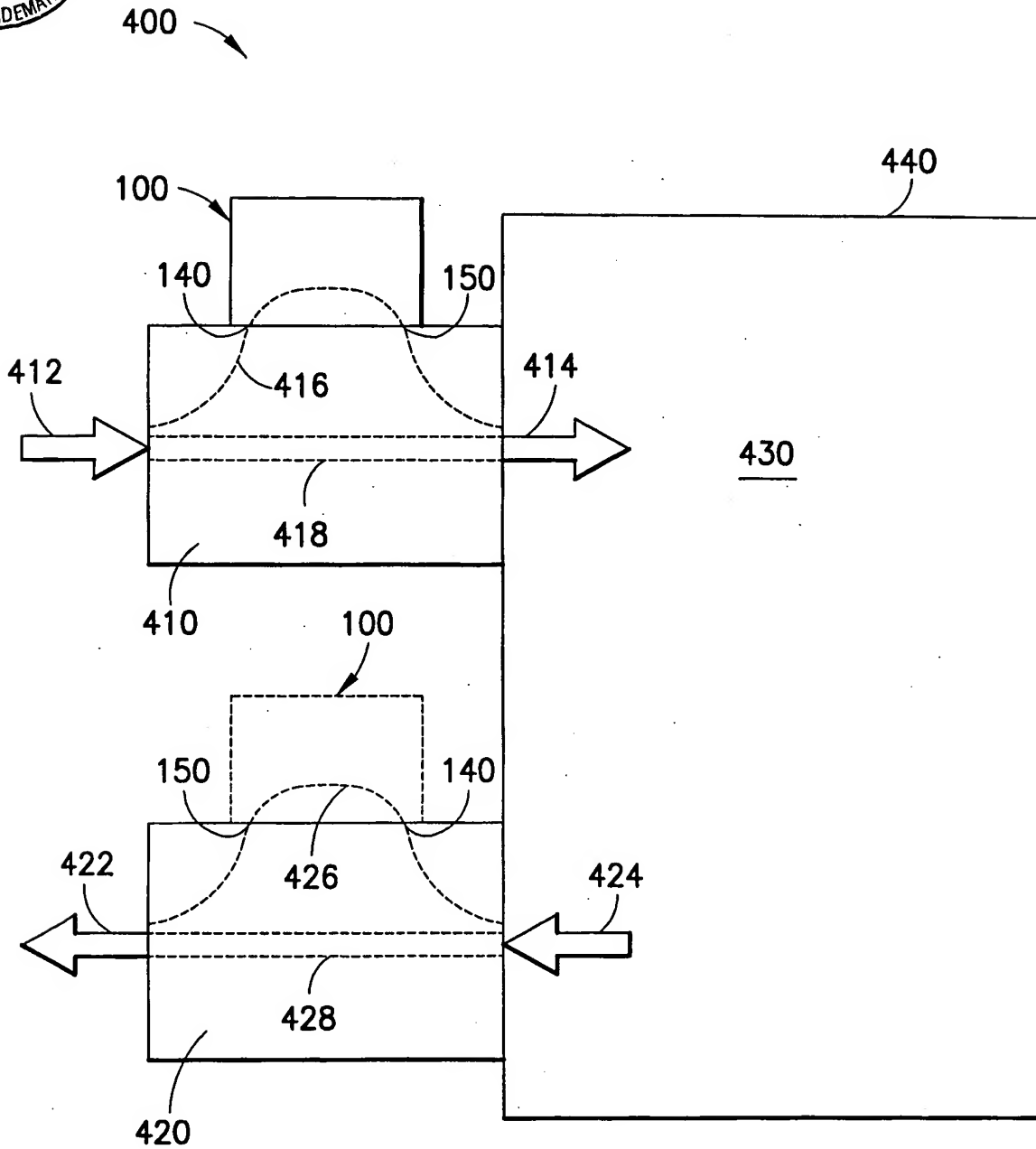


FIG. 4